

Notice of References Cited	Application/Control No. 10/580,231		Applicant(s)/Patent Under Reexamination EDWIN ET AL.	
	Examiner DANIEL C. MCCRACKEN		Art Unit 1793	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0151654	08-2004	Wei et al.	423/447.3
*	B	US-6,905,544	06-2005	Setoguchi et al.	117/105
*	C	US-5,102,647	04-1992	Yamada et al.	423/447.3
*	D	US-4,268,359	05-1981	Rammler et al.	201/31
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Venegoni, et al., Parametric study for the growth of carbon nanotubes by catalytic chemical vapor deposition in a fluidized bed reactor, Carbon 2002; 40: 1799-1807.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.